

Message Text

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PAGE 01 STATE 173962
ORIGIN EB-08

INFO OCT-01 EUR-12 ISO-00 COME-00 DODE-00 NSAE-00
ICA-11 TRSE-00 SOE-02 DOE-15 CIAE-00 /049 R

DRAFTED BY EB/ITP/EWT:CECOLE'
APPROVED BY EB/ITP /EWT:RPRACHT
COMMERCE/OEA:MKRAVETZ
-----082609 111152Z /46

R 110032Z JUL 78
FM SECSTATE WASHDC
TO AMEMBASSY PARIS

C O N F I D E N T I A L STATE 173962

USOECN, EXCON

E.O. 11652:GDS

TAGS:ESTC, COCOM, BU, US

SUBJECT: U.S. CENTRIFUGAL WAFER PROCESSING SYSTEM TO
BULGARIA - IL 1355

REF: A. COCOM DOC (78) 428 B. 78 PARIS 21173

IN RESPONSE TO GERMAN QUESTION REF B, THE STATEMENT
REFERING TO "...DISCRETE STANDARD SEMI-CONDUCTOR DEVICES.." WAS
INTENDED TO COMMUNICATE THE FACT THAT THE MACHINES LOGIC
FUNCTIONS ARE NOT CONTROLLED BY CIRCUITS INTEGRATED INTO A
SINGLE MICRO-PROCESSOR PACKAGE. THE LOGIC FUNCTIONS ARE MOST
CERTAINLY COMPOSED OF SEVERAL SEPARATE (DISCRETE) CMOS AND
TTL INTEGRATED CIRCUITS NOT SPECIALLY DESIGNED OR PROGRAMMED
FOR THE CENTRIFUGAL WAFER PROCESSING SYSTEM. THE AFOREMENTIONED
STANDARD INTEGRATED CIRCUITS ARE READILY AVAILABLE FOR ANY
IMAGINATIVE USE BY LOGIC DESIGNERS. VANCE
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PAGE 02 STATE 173962

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Message Attributes

Automatic Decaptioning: X
Capture Date: 01 jan 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: SEMICONDUCTOR DEVICES
Control Number: n/a
Copy: SINGLE
Draft Date: 11 jul 1978
Decaption Date: 01 jan 1960
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 20 Mar 2014
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1978STATE173962
Document Source: CORE
Document Unique ID: 00
Drafter: CECOLEV
Enclosure: n/a
Executive Order: GS
Errors: N/A
Expiration:
Film Number: D780283-0343
Format: TEL
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1978/newtext/t19780774/aaaacjwu.tel
Line Count: 55
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 8aebce77-c288-dd11-92da-001cc4696bcc
Office: ORIGIN EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: n/a
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 18 may 2005
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2049914
Secure: OPEN
Status: NATIVE
Subject: U.S. CENTRIFUGAL WAFER PROCESSING SYSTEM TO BULGARIA - IL 1355
TAGS: ESTC, BU, US, COCOM
To: PARIS
Type: TE
vdkgvwkey: odb://SAS/SAS.dbo.SAS_Docs/8aebce77-c288-dd11-92da-001cc4696bcc
Review Markings:
Sheryl P. Walter
Declassified/Released
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